

PATENT APPLICATION  
Q-51885

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akiaka KIMURA

Appln. No.: 37 C.F.R. §1.53(d) Continuation  
of 09/161,981, filed September 29, 1998

Group Art Unit: 2812

Confirmation No.: 8269

Filed: September 29, 1999

Examiner: Mulpur, S.

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND  
METHOD FOR DEPOSITING SEMICONDUCTOR LAYERPRELIMINARY AMENDMENTCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Preliminary to examination of the above-identified Application, please make the  
following amendments:#-24/B  
5/2/3  
FAX RECEIVED  
MAY 02 2003  
TECHNOLOGY CENTER 2800

FILED

APR 23 2003